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AMENDMENTS TO THE CLAIMS

- 1. (Original) A method for treating an implant surface intended for implantation into bone tissue c h a r a c t e r i s -e d in providing a microroughness comprising pores and peaks having a pore diameter of ≤ 1 µm, a pore depth of ≤ 500 nm, and a peak width, at half the pore depth, of from 15 to 150% of the pore diameter.
- 2. (Original) A method according to claim 1, wherein the pore diameter is within the range of 50 nm to 1 μ m and the pore depth is within the range of 50 to 500 nm.
- 3. (Currently Amended) A method according to claim 1-or claim 2, wherein a root-mean-square roughness (R_q and/or S_q) of ≤ 250 nm is provided.
- 4. (Currently Amended) A method according to any one of claims 1-3 claim 1, wherein the implant surface is a metallic implant surface.
- 5. (Original) A method according to claim 4, wherein the microroughness is provided by treating the metallic implant surface with an aqueous solution of hydrofluoric acid.
- 6. (Original) A method according to claim 5, wherein the concentration of the hydrofluoric acid is less than 0.5 M.

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7. (Original) A method according to claim 6, wherein the metallic implant surface is treated for an etching period of up to 180 sec at room temperature.

- 8. (Original) A method according to claim 7, wherein the concentration of the hydrofluoric acid is 0.1 M and the etching period is up to 60 sec at room temperature.
- 9. (Currently Amended) A method according to any one of claims 1-8 claim 1, further comprising providing a macroroughness on the implant surface prior to providing the microroughness.
- 10. (Original) A method according to claim 9, wherein the macroroughness is provided by blasting the implant surface.
- 11. (Currently Amended) A method according to any of claims 1-10 claim 1, wherein said metallic implant surface is made of commercially pure titanium or an alloy of titanium.
- 12. (Currently Amended) An implant for implantation into bone tissue having an implant surface at least part of which has been treated with a method according to any of claims 1-11 claim 1.
- 13. (Original) An implant for implantation into bone tissue having an implant surface c h a r a c t e r i s e d in that at least a part of the implant surface comprises a microroughness which

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comprise pores and peaks having a pore diameter of ≤ 1 µm, a pore depth of ≤ 500 nm, and a peak width, at half the pore depth, of from 15 to 150% of the pore diameter.

- 14. (Original) An implant according to claim 13, wherein the pore diameter is within the range of 50 nm to 1 μ m and the pore depth is within the range of 50 to 500 nm.
- 15. (Currently Amended) An implant according to claim 13-or claim 14, wherein the microroughness has a root-mean-square roughness (R_a and/or S_a) of ≤ 250 nm.
- 16. (Currently Amended) An implant according to any-one of claims 13-15 claim 13, wherein the implant surface further comprises a macro-roughness.
- 17. (Currently Amended) An implant according to any one of claims 13-16 claim 13, wherein said implant is a metallic implant.
- 18. (Original) An implant according to claim 17, wherein said metallic implant is made of commercially pure titanium or an alloy of titanium.
- 19. (Currently Amended) An implant according to any one of claims 13-18 claim 13, wherein the implant is a dental implant.

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20. (Currently Amended) An implant according to any one of claims 13-18 claim 13, wherein the implant is an orthopaedic implant.